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In both light optics and electron optics, the amplitude of a wave scattered by an object is an observable that is usually recorded in the form of an intensity distribution in a real space image or a diffraction image. In contrast, retrieval of the phase of a scattered wave is a well-known challenge, which is usually approached by interferometric or numerical methods. In electron microscopy, as a result of constraints in the lens setup, it is particularly difficult to retrieve the phase of a diffraction image. Here, we use a “defocused beam” generated by a nanofabricated hologram to form a reference wave that can be interfered with a diffracted beam. This setup provides an extended interference region with the sample wavefunction in the Fraunhofer plane. As a case study, we retrieve the phase of an electron vortex beam. Beyond this specific example, the approach can be used to retrieve the wavefronts of diffracted beams from a wide range of samples. Published by AIP Publishing. https://doi.org/10.1063/1.4998595

In light optics and electron microscopy, the intensity distribution in a real space image or a diffraction image of a sample is usually recorded, while phase information is lost. For this reason, significant effort has been aimed at developing methods that can be used to retrieve phase distributions. Retrieval of the phase from both real space and diffraction images is particularly important in electron microscopy, as it is sensitive to built-in electric and magnetic fields in materials, crystallographic structure, and local strain, as well as providing a route to enhancing contrast from weakly scattering objects.1–4 A recent addition to the list of objects, for which characterization of the phase is important comes from the formation of electron vortex beams (EVBs), which possess orbital angular momentum (OAM) $L = \ell \hbar$ with topological charge $\ell$, where $\hbar$ is the reduced Planck constant.5,6 EVBs are usually generated by diffraction from nanofabricated computer-generated holograms (CGHs) and are currently receiving considerable attention for both fundamental research and applications.7–9 A key difficulty in phase retrieval of EVBs results from the fact that they possess phase singularities in the electron beam transverse plane.10

All of the methods that are used to retrieve the phase of a wavefront can be related to the original idea of Gabor of electron holography.11 He proposed that the relative phase of a sufficiently coherent wave system can be retrieved by interference with a known reference wave (REF). Depending on the angle between the reference wave and the normal to the hologram plane during the recording step, holographic methods can be divided into either in-line (parallel) or off-axis (tilted) modes. The in-line approach is an elegant, yet computationally demanding, approach to phase reconstruction. It is based on the recording of a number of images, either at different defocus values or in real and diffraction space. The phase retrieval processes is then either iterative, as in the case of the Gerchberg–Saxton algorithm, or deterministic, as in the case of the transport of intensity equation (TIE).12 An in-focus version of the real space in-line holography method, which is potentially very powerful but still under development, is based on the use of electron phase plates.13 A more widely used and direct method of phase retrieval in an electron microscope is based on the interference of a wavefunction of interest with a tilted reference wave. This approach typically involves using an electron biprism14 to split a single wavefront into two different nearly plane wavefronts, only one of which passes through the sample, in order to produce an electron interference pattern15,16 or an off-axis electron hologram.17–20 The disadvantages of this approach include the limited size of the interference region that can be formed and the need for a perfectly unperturbed reference wave. Moreover, the interference pattern is not recorded directly in the biprism plane, but at some distance from it, in order to allow superposition. A comparison between in-line and off-axis electron holography has recently been reported.21

Phase retrieval methods are equally important for diffraction images, which can be recorded from a large sample area and have many applications, especially for X-rays, where the wavelength and lensing make imaging more difficult (see, e.g., Refs. 22–24). Phase retrieval methods that are
based on iterative approaches have also been applied to nano-
beam electron diffraction \(^{25}\) in both high-resolution \(^{26}\) and low-resolution \(^{27,28}\) scanning transmission electron microscopy (STEM). In electron crystallography, high-resolution real space images and diffraction images have been combined to solve the crystallographic phase problem.\(^{29}\)

Since EVBs, just like many other synthetic beams, are generated holographically in the Fraunhofer plane of a CGH, the phase retrieval must be carried out in that plane. Previously, accurate real space characterization of a CGH was simply used to infer the phase of an EVB.\(^{30–32}\) Interference in the out-of-focus Fresnel regime has also been carried out.\(^{33}\) However, a direct measurement of the phase of an EVB would be preferable, in particular, when such a wavefunction is produced by elastic electron-sample interaction. Unfortunately, the standard experimental configuration of the biprism-based approach to electron holography cannot be transferred directly to diffraction, as the Fraunhofer diffraction pattern of the reference wave would simply be an image of the source, i.e., ideally a point. In addition, it has been demonstrated that TIE, in its simplest implementation, cannot be used to provide a map of vortex singularities, but instead requires a complicated generalization\(^{34}\) or astigmatic illumination, as reported for X-ray optics.\(^{35}\)

The aim of the present paper is to demonstrate that, by using CGHs and holographic reconstruction methods, it is possible to combine the advantages of large area illumination and in-focus interference to achieve phase retrieval in the diffraction plane, thereby enabling phase retrieval of an EVB.

In order to obtain an appropriate interference pattern in the diffraction plane, it is necessary to structure the reference beam in a controlled manner. A simple case such as a Bessel beam,\(^{31,36}\) whose CGH is characterized by a linear phase gradient in the radial direction, only produces rings. In contrast, a defocused beam (DB) is associated with a quadratic variation in phase and produces an extended diffraction pattern that can be superimposed onto the diffraction pattern of an object. This concept is similar to diffraction holography in X-ray experiments.\(^{27,28}\) However, in our case the technology that is used to produce nanofabricated holographic phase plates for the generation of EVBs can also be used to structure the reference wave.

In the present study, two closely spaced CGHs are fabricated using focused ion beam (FIB) milling on a single SiN membrane following the same procedure that is normally used to produce phase holograms.\(^{30–32}\) One of the holograms is the DB-CGH, which has a parabolic phase-modulation so that it produces a reference DB. The other hologram is the EVB-CGH, which is used to generate an EVB with an OAM \(L_z\) of \(10\mu\text{m}\). The phase that is imprinted on the DB-CGH takes the form

\[
\phi(\rho, \theta) = \pi \left(1 + \frac{1}{2} \text{sign}(\sin(k_{\text{carr}} \rho \sin \theta + a \rho^2))\right),
\]

where the term \(\text{sign}\) describes a function that is zero for zero argument and \(\text{sign}(x) = x/|x|\) in all other cases, \(\rho, \theta\) are polar coordinates, \(k_{\text{carr}}\) is the carrier frequency, and \(a\) is a real value that is related to the curvature of the reference DB. Such a parabolic phase hologram also produces a parabolic wavefront in the Fraunhofer plane. This can be regarded as an extension of the Fourier transform (FT) of a Gaussian function.\(^{1}\)

As the desired shape of the vortex beam is a Laguerre Gauss beam,\(^{39,40}\) we used a complicated encoding of phase and amplitude information\(^{39,40}\) in the CGH. For the sake of discussion, we assume here that the phase imprinted on the EVB-CGH takes the form

\[
\phi'(\rho, \theta) = \text{mod}(\langle k_{\text{carr}} \rho \sin \theta + \ell \theta \rangle, 2\pi),
\]

where the function \(\text{mod}(m, n)\) is the remainder of \(m\) on division by \(n\) and \(k_{\text{carr}}\) is chosen to be the same for both holograms so that the centers of the first diffraction orders coincide. The value of \(\ell\) was set to 10.

Images of the two CGHs recorded in a scanning electron microscope (SEM) are shown in Fig. 1(a), while a sketch of the electron-optical setup in the transmission electron microscope (TEM) is shown in Fig. 1(b). The SEM image was recorded at an accelerating voltage of 10 kV using an Everhart-Thornley detector. For comparison, Fig. 1(c) shows the setup for a plane reference wave, which produces no significant overlap with the object beam in the focal plane.

Experiments were carried out at 200 kV in a JEOL 2200 TEM equipped with a Schottky field emitter. The microscope was operated in “LOW MAG” mode, with the “objective min-

lens” used as the main lens.\(^{30–32}\) In this electron-optical config-

uration, we were able to observe diffraction images from the holograms separately by positioning the objective lens aperture (OLA) almost exactly in a plane conjugate to the specimen. Since high lateral coherence is required, nominally covering the full area of the two holograms (on the order of 20 \(\mu\text{m}\)), we optimized the illumination system to achieve highly parallel illumination, with the C3 condenser lens almost at its maximum excitation. When the OLA was removed, the diffraction images from the two holograms could be superimposed. The centers of both diffraction images were coincident, while the first diffraction orders were concentric. In detail, the centers of the two CGHs were separated by a distance \(D = 9.9 \mu\text{m}\), while the diameters of the DB-CGH and EVB-CGH were 9.8 and 6.5 \(\mu\text{m}\), respectively.

Diffraction images generated by the DB-CGH and EVB-

CGH are shown in Figs. 2(c) and 2(g), respectively, while corresponding simulations are shown in Figs. 2(d) and 2(h).

![FIG. 1. (a) SEM images of the EVB-CGH (top) and the DB-CGH (bottom) recorded at an angle of 52°. (b) and (c) Simplified ray diagrams of interference in the focal plane of an object wave (OBJ) diffracted by the EVB-CGH with a reference wave (REF) that is either a DB diffracted by the DB-CGH (b) or a plane wave (c). The objective lens aperture (OLA) that is used to obtain the diffraction image of each hologram has been omitted for clarity. The plane reference wave transforms into a point in the back focal plane and therefore cannot be used for interferometry.](image-url)
The DB exhibits circular diffraction, while the EVB shows circular symmetry and a dark region in the central area. As a result of hologram imperfections, the intensity is reduced at higher frequencies, i.e., on the lower side of Fig. 2(c), which can be compared with the simulation in Fig. 2(d). The curvature and size of the reference “defocused beam” are chosen so that the intensities of the first order diffracted beams are comparable in the superposition region.

For the first order diffracted beam alone, in the Fraunhofer diffraction plane with in-plane coordinates \( \vec{q} \), the electron wavefunction of the DB reference beam can be written in the form

\[
\psi_{DB}(\vec{q}) = A \exp \left( i \frac{\pi^2 \vec{k}_\perp^2}{a} \right) \exp \left( i \vec{k}_\perp \cdot \vec{D} \right),
\]

where the origin of the \( x, y \) coordinates is taken to be at the center of the EVB-CGH, while the center of the reference DB-CGH is located at \( \vec{D} \). The wave that results from superposition of the two reconstructed waves takes the form

\[
\psi_{DB}(\vec{k}_\perp) + \psi_{EVB}(\vec{k}_\perp) = A \exp \left( i \frac{\pi^2 \vec{k}_\perp^2}{a} \right) \exp \left( i \vec{k}_\perp \cdot \vec{D} \right) + B \exp (i \phi),
\]

where \( \psi_{EVB} \) is the EVB wavefunction (or in general any wavefunction whose phase \( \phi(\vec{k}_\perp) \) needs to be retrieved) and \( A \) and \( B \) are the amplitudes of the two diffracted waves. The full interference pattern can be written

\[
I(\vec{k}_\perp) = A^2 + B^2 + 2AB \cos \left( \frac{\pi^2 \vec{k}_\perp^2}{a} + \phi(\vec{k}_\perp) + \vec{k}_\perp \cdot \vec{D} \right).
\]

The successive experimental steps are shown in Fig. 3. The interference pattern is visible in Figs. 3(c) and 3(d). In the present case, we expect

\[
\phi(\vec{k}_\perp) = \ell \tan \left( \frac{k_y}{k_x} \right).
\]

Just as for an isolated DB, nearly horizontal fringes are visible due to the zero order tails superimposing onto the first order diffracted beam. However, these fringes are nearly orthogonal to the interference fringes that carry the EVB phase information and can be distinguished easily in the reconstruction algorithm.

Apart from the parabolic phase term, Eq. (5) resembles the interference effect in biprism-based off-axis electron holography. We can therefore apply the well-known algorithms for phase reconstruction that are used in those experiments. The steps are shown in the lower part of Fig. 3. The digitally calculated discrete Fourier transform (FT) of the intensity can be written in the form

\[
FT(I) = (A^2 + B^2) \delta(\vec{q}) + AB \left( \exp \left( i \frac{\pi^2 \vec{k}_\perp^2}{a} + i \phi(\vec{k}_\perp) \right) \right) \times \delta(\vec{q} + \vec{D}) + c.c.,
\]

where \( c.c. \) indicates the complex conjugate of the last term and \( FT(I) \) is characterized by a strong peak at the origin and...
two sidebands centered at $q \approx \pm D$, as shown in Fig. 3(e). If one of these sidebands is isolated, translated to the center of the $q$ plane, and digitally inverse Fourier transformed, then the final complex image is

$$f(\hat{k}_\perp) = AB \exp\left(i \frac{\pi \hat{k}_\perp^2}{a} + i \phi(\hat{k}_\perp)\right). \quad (8)$$

The reconstructed phase is shown in Fig. 3(f). The saturation of the colors represents the intensity, while the hue represents the phase. The phase is still affected by a parabolic term, which can be removed analytically. However, this term is rotationally symmetric and does not affect the characterization of the OAM. Corresponding simulations are shown for the ideal interferometry [Figs. 3(g) and 3(h)] and the reconstruction [Fig. 3(i)]. Differences between the simulations and the experimental results arise from limitations of hologram fabrication.

In Fig. 4, we show the OAM decomposition based on the reconstructed phase, as a benchmark of the reconstruction, obtained by transforming the phase in Fig. 3(f) to polar coordinates and Fourier transforming, as explained elsewhere. The coefficients $C_{OAM=\ell}$ appear in the decomposition of the azimuthal part of the wavefunction according to the expression $\psi(\theta) = \sum_{\ell=-\infty}^{\infty} C_{OAM=\ell} \exp(i \ell \theta)$. It should be noted that this distribution depends only on the azimuthal structure of the beam, and it is not affected by the parabolic phase of the DB reference developing in the radial direction. A near-exact Fraunhofer condition was achieved based on minimization of the EVB size. The resulting narrow distribution is peaked at an OAM of $10h$ as we aimed for. Whereas, in principle, the leading coefficient could reach a value of 80%, we obtain a slightly broadened distribution, almost certainly due to hologram imperfections or the limited coherence of the electron beam. Both of these effects can act as a low-pass filter and distort the reconstructed image. Based on a comparison of the experimental data with simulations, we estimated an equivalent blurring effect of the hologram by a Gaussian with a full width at half maximum of 80–100 nm. This effect results from fabrication and coherence problems. The blurring induces a change in beam amplitude that produces a disturbance in the OAM decomposition. Nevertheless, the general reconstruction framework is reliable, since we still observe 50% of the intensity in the $10h$.

Although the application of the approach to an EVB is a case study, this method can be used in a more general context, especially for the diffraction of micron-sized objects ranging from magnetic materials to strained semiconductors and biological structures. In the present example, we used an approach based on a carrier frequency for both the object and the reference hologram, in order to achieve more precise phase control. However, holograms and objects without a carrier frequency can also be considered. It is also possible to push the maximum frequency towards nm$^{-1}$ scales by using a different setup of the reference “defocused beams,” improved nanofabrication, and/or the use of holograms located in different apertures in the electron microscope column.

Outside electron microscopy, the concept of diffraction holography using a non-plane reference wave has also been proposed for X-rays. However, the use of a pinhole to generate the reference wave then made the interference effect weak. In contrast, for electrons, it is possible to equalize the intensities of the two beams to maximize the interference effects.

In summary, we have demonstrated the use of a defocused beam with a parabolic phase profile for object phase retrieval and applied it to an electron vortex beam. In electron microscopy, the technique permits the phases of diffraction images to be retrieved directly in Fraunhofer conditions, providing opportunities for large area interferometry and easy interpretation of the results without the influence of Fresnel fringes. Here, we could use the approach to confirm that a vortex beam has an intended average OAM value of $10h$.

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A characterization of OAM purity in our hologram as in Ref. 29 with the method in Ref. 31 led to a typical purity in OAM decomposition of 80%.